

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>				Docket Number (Optional) 14274		Application Number 09/774,921		
				Applicant(s) Hideaki SHIRAISHI		Filing Date Jan. 31, 2001		Group Art Unit 2871
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
DN		52-080855	7/6/97	Japan	—	—	—	—
DN		59-182421	10/17/84	Japan	—	—	—	—
DN		53-41945	9/13/51	Japan	—	—	—	—
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
EXAMINER <i>DNUYEN</i>				DATE CONSIDERED <i>06/12/03</i>				
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DRUYEN

DATE CONSIDERED

06/12/03

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